

Notice of References Cited	Application/Control No. 10/520,935	Applicant(s)/Patent Under Reexamination NUMMINEN, MICHAEL	
	Examiner Harry Liu	Art Unit 3662	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-3,803,625 A	04-1974	Nemit, Jeffrey T.	342/368
*	B	US-5,955,994 A	09-1999	Staker et al.	343/700MS
*	C	US-5,973,641 A	10-1999	Smith et al.	342/372
*	D	US-5,973,638 A	10-1999	Robbins et al.	342/172
*	E	US-6,198,434 B1	03-2001	Martek et al.	342/373
*	F	US-6,236,363 B1	05-2001	Robbins et al.	342/360
*	G	US-6,351,243 B1	02-2002	Derneryd et al.	343/754
*	H	US-2002/0080073 A1	06-2002	Wastberg, Bo Gunnar	343/700.0MS
*	I	US-6,487,423 B1	11-2002	Johansson, Bernt	455/562.1
*	J	US-6,567,034 B1	05-2003	Yu, Kai-Bor	342/16
*	K	US-6,795,018 B2	09-2004	Guo, Yingje Jay	342/372
*	L	US-2006/0114155 A1	06-2006	Numminen, Michael	342/383
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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